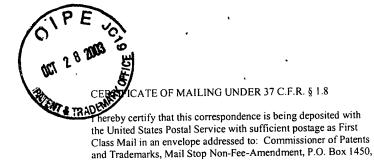
PTO/SB/21 (08-03) Approved for use through 08/30/2003. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE
the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. **Application Number** 09/829.587 TRANSMITTAL Filing Date April 9, 2001 First Named Inventor **FORM** P<del>: La</del>gtev Art Unit 1763 (to be used for all correspondence after initial filing) **Examiner Name** R. Zervigon Attorney Docket Number SPUTT-56141 Total Number of Pages in This Submission **ENCLOSURES** (Check all that apply) After Allowance communication to Technology Center (TC) Drawing(s) Fee Transmittal Form Appeal Communication to Board Licensing-related Papers of Appeals and Interferences Fee Attached Appeal Communication to TC 1 Petition (Appeal Notice, Brief, Reply Brief) Amendment/Reply Petition to Convert to a Proprietary Information Provisional Application After Final Power of Attorney, Revocation Status Letter Affidavits/declaration(s) Change of Correspondence Address Other Enclosure(s) (please Terminal Disclaimer Identify below): Extension of Time Request **POSTCARD** Request for Refund **Express Abandonment Request** CD, Number of CD(s) Information Disclosure Statement Remarks Certified Copy of Priority Document(s) Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53 SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT ELLSWORTH R. ROSTON, ESQ., REG. NO. 16,310 Firm FULWIDER PATTON LEE & UTECHT, LLP Individual name Signature Date OCTOBER 24, 2003 CERTIFICATE OF TRANSMISSION/MAILING I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below. Typed or printed name ELLSWORTH R. ROSTON, ESQ., REG. NO. 16,310 Ellownth R. Rooten Date OCTOBER 24, 2003 Signature

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS, SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



Atexandria, VA 22313-1450 on October 24, 2003.

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of

Inventor: Laptev, P.

Serial No. 09/829,587

Filed: April 9, 2001

For: SYSTEM FOR, AND METHOD OF, ETCHING A SURFACE ON A WAFER

Examiner: Zervigon, R.

Group Art Unit: 1763

Confirmation No.: 7932

Client ID/Matter No.: SPUTT-56141

Date: October 24, 2003

Los Angeles, California 90045

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT UNDER RULE 116**

This Amendment is response to the Office Action of 07/11/03. Please amendment and reconsider the above-referenced application.

## IN THE CLAIMS:

Please change the claims as follows:

1. (Currently Amended) In combination for etching an insulating layer in a wafer to present a clean and fresh surface on the insulating layer for deposition,

a conduit for molecules of an inert gas,